



# Research and Development Section Indian Institute of Technology Guwahati Guwahati-781039, Assam

Applications are invited for **Walk-in-interview** of the following post(s) for **Contractual recruitment** in the project entitled, "**Indian Nanoelectronics Users' Programme - Idea to Innovation (INUP-i2i)**" at **Centre for Nanotechnology, IIT Guwahati**.

**Date: 13<sup>th</sup> September 2023 (Wednesday)**

**Time: 10:00 A.M**

**Venue: Conference Room, Centre for Nanotechnology, IIT Guwahati**

Sl. No.	Project Staff Designation	Number of Vacancies	Pay Recommended (Rs.)	HRA Required (Rs.)	Medical Required (Rs.)	Total Amount (Rs.)	Duration of Appointment in months	Qualifications
1	Senior Project Scientist	01	60000	Yes 10800.00	1250.00	72050.00	11	PhD degree + 3 yrs exp.or Master`s degree in Science + 6 yrs exp. <b>Preferable Expertise:</b> Expertise in NanoScience, Nanotechnology, Nanobiology, Nanoelectronics and hands-on experience in Nanofabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micromachining, Wire Bonding, Double Sided Mask Aligner, Thermal/E-Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/Diffusion Furnaces, Reactive Ion Etching, FESEM EBL, Mask Writer, Raman, IR, Cryogenic DC Probe Station and Pulse parametric Analyzer

**How to apply and selection process:** Candidates have to appear in the walk-in-interview at 10:00 AM on 13th September 2023 (Wednesday). They have to send advance copy of their CV mentioning all educational qualifications, experience etc. to [nano\\_off@iitg.ac.in](mailto:nano_off@iitg.ac.in) within 10.09.2023 (5PM). Selection will be based on the performance of the candidate in the interview. Candidates will not be sent any call letter separately.

**For any clarification, contact:** Nano Office, Centre for Nanotechnology, IIT Guwahati

**Email:** nano\_off@iitg.ac.in

**Phone:** 3075

**No TA/DA will be paid to the candidates for appearing in the test and interview.**

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**Assistant Registrar (R&D)**